

Docket Number: 081468-0306993

PATENT APPLICATION

Client Reference: P-1748.000-US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

EMIEL JOZEF MELANIE EUSSEN, et al. Group Art Unit: 2877

Application No.: 10/720,752 Examiner: Samuel A. Turner

Filed: November 25, 2003 Confirmation No.: 2765

For: LITHOGRAPHIC INTERFEROMETER SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference(s) has been considered, per MPEP § 609.

This Information Disclosure Statement is being filed just after the recent submission of a Request for Continued Examination on October 16, 2007. No certification or fee is required.

Application No.: 10/720,752

Attorney Docket No.: 081468-0306993

Inventors: EMIEL JOZEF MELANIE EUSSEN, et al.

English-language Abstracts of the non-English language references are attached hereto.

Respectfully Submitted,

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